

Docket No.: 107176.00007  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	Attorney Docket No. 107176.00007
Tadahiro OHMI et al.	Confirmation No.: 1605
Application No.: 09/864,376	Art Unit: 1716
Filed: May 25, 2001	Examiner: Not Yet Assigned
For: PLASMA PROCESSING APPARATUS AND PLASMA PROCESSING METHOD	

**STATUS INQUIRY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

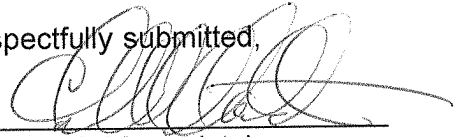
Sir:

It is respectfully requested that the representative named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive an Office Action from the Patent and Trademark Office.

Applicant believes no fee is due with this response. However, if a fee is due, please charge our Deposit Account No. 01-2300, under Order No. 107176.00007 from which the undersigned is authorized to draw.

Dated: December 13, 2010

Respectfully submitted,

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